

<b>Notice of References Cited</b>	Application/Control No. 10/525,770	Applicant(s)/Patent Under Reexamination SHIRAI ET AL.	
	Examiner Khoa D. Huynh	Art Unit 3751	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0019962	02-2004	Sato et al.	4/420.4
*	B	US-4,581,779	04-1986	Matsui et al.	4/420.2
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 06-017471	01-1994	Japan	Koji et al.	E03D 9/08
	O	JP 2001-065035	03-2001	Japan	Ikuya et al.	E03D 9/08
	P	JP 2000-333884	12-2000	Japan	Yasukazu	A47K 13/30
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.